

I hereby certify that this paper and fee are being TRANSMITTED VIA FACSIMILE TO: Assistant Commissioner for Patents, P. O. Box 1450, ALEXANDRIA, VA 22313-1450. Date of Deposit: 10/11/05. Name of Person Making Deposit: Linda Roberts-Jackson

Linda Roberts-Jackson
Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of _____:
Edward Barth, et al.

October 11, 2005
Group Art Unit: 2822

Serial No.: 10/659,778

Confirmation No. 5616
Examiner: Novacek, Christy L.

Filed: 9/10/03 :

International Business Machines Corporation
2070 Route 52
Hopewell Junction, NY 12533

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OCT 11 2005

TITLE: Dual-Damascene Interconnect Structure Using Low Stress Fluorosilicate Insulator with Copper Conductors

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit the PTO-1449 and references attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

The Commissioner is hereby authorized to charge the fee in 37 CFR 1.17(P) for submission of an Information Disclosure Statement to Deposit Account No. 09-0458.

Respectfully submitted,
Edward Barth, et al.

By *Lisa J. Ulrich*

Lisa J. Ulrich, Registration No. 45,168
Telephone No. 845-894-3338

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